

Notice of References Cited	Application/Control No. 10/826,267	Applicant(s)/Patent Under Reexamination KIM ET AL.	
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	C	US-6,424,397	07-2002	Kuo, Chen-Lung	349/139
	D	US-5,808,717	09-1998	Van Aerle, Nicolaas A. J. M.	349/129
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